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This is a WORD Template form. Press enter or tab to move to each field. Please fill out this form as completely as possible. If the allotted space is not sufficient, use a separate sheet. Have your manager sign the form and forward it to the Patent Section of the Law Department, MS301. Please attach any drawings and technical descriptions that are available and assemble copies of the background articles, books, advertisements, etc. for use by your patent attorney.

4.	Inventor(s) Full Name(s) Mark Boone Ralph Denzi Paul Gerrish Mike Mattes Tyler Mueller Jeff Van Wagoner	Employee Number 22868 23268 22224 61277 24051 33831	Mail Stop S576-10 S576-22 S576-10 S576-10 S576-22	Home Address (Include Zip Code) 518 W. San Remo St., Gilbert, AZ 85233 16016 Westwind Way, Tempe, AZ 85283 14838 S. 30 <sup>th</sup> St., Phoenix, AZ 85048 2173 E. Kempton Rd., Chandler, AZ 85225 4847 E. Francisco Dr. #248, Phoenix, AZ 85044 2877 E. Libra St. Gilbert, AZ 85234		
2.	Title of Invention: <u>Bumpable 1KV DMOS Davica</u> .					
3.	Summary of the Invention: 1000V vertical mosfet, which is bumped, having a drain contact on the front surface of the dis.  Orain contact is made via a trench through the epi region down into the substrate. The mosfet obtains a low Roson by having a high cell packing density, thus creating a multitude of current paths in parallel					
4.	How have others eddressed this problem (List and ettach any palents, books, articles, devices, Medtronic or competitor's products, or other background materials you used or which may be prior art)? <u>wire bond or other chin carriers</u>					
5.	The invention is described on pages of Lab Notebook No (Please attach copy).					
	See Medtronic Microelectronics Center Specification 3212963.					
8.	When was a device built which included the invention? <u>Development is underway.</u>					
	Who built it? Medironic Microsisctronics Center Where is it? 2343 W. 10" Pisce, Tempe, AZ 85281					
	Who has supporting documents? SST Organization has design rule flow and Wafer Fab has a Promis Process Flow					
	Who witnessed tests?	When and where	?			
¥.	Discuss the problems which the invention is designed to solve, referring to any prior devices of a similar nature with which you may be familiar. The invention provides a 1KV DMOS device which can be solder reflow attached to a circuit board.  This invention sliminates the need for wirebondable devices.					
8.	State the advantages of the in	ivention over preser	ntiy known device	s, systems or processes. The invention provides a		

List all known and other possible uses for the invention. Other applicable high voltage device technologies

bumped, surface mountable 1KV DMOS device.

drawings. See attached description and drawings

application may be filed after one year from such date.)

S.

10.

11.

12.

mosfet.
Sale or Publication (Needed to establish the date of any printed publication, public use or sale, since no U. S. patent

the epitaxial silicon, allowing contact to the substrate-drain of the device (see Figure 1). A bumped 1KV DMOS vertical.

List all features of the invention that are believed to be novel. Eiches in the <100> surface orientation to create a "trench" in

Specifically describe the invention and its operation. You may use and attach copies of sketches, prints, photographs and

illustrations which should be signed, witnessed and dated. Use numbers and descriptive names in descriptions and

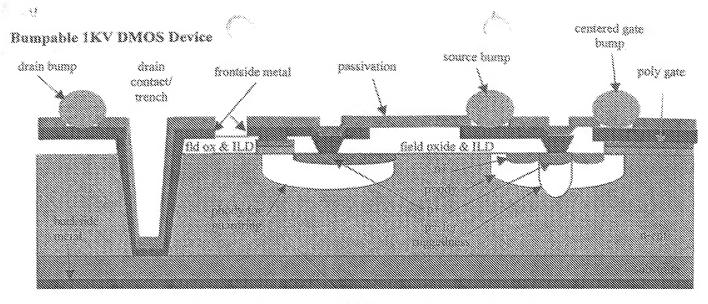


Figure 1 - Bumpable 1KV DMOS Device Simplified Cross Section

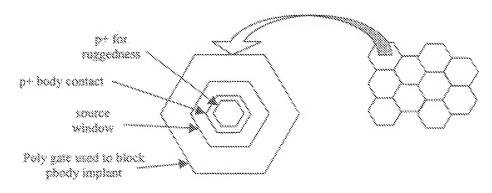


Figure 2 - Packing Denvity of the Haxagonal MOSFET Cell Contraction with Expanded View of Layout Cell

## DEVICE CLAIMS (General)

- 1. Trench etched in the <100> crystal orientation; Allows drain-substrate contact,
- 2. Centered Gate Bump allows a more consistent gate voltage across the die.
- 3. Metal on backside of water reduces Ridson of DMOS device.
- 4. Plurality of cells to maximize packing density of DMOS cells by using hexagonal cell construction.
- 3. Allows for smaller hybrid packaging area by eliminating the need for wire bonds and the space surrounding the die.
- Field plates in the guardrings contact both metal and poly to alter the surface field potential.
- 7. Uses the patterned polysilicon as a blocking mask for the phody implant.
- 8. For use in implantable medical devices.

Taken together we believe that the above claims, or subset, may be parentable.

## DEVICE CLAIMS (Specific)

- 1. Device having a phody diffusion junction depth between 6-9um.
- Device having a p+ junction extending slightly farther than the phody diffusion for improved avalanche/ruggedness.
- Device having a p+ notree/drain implant overlapping the n+ source region for use as a body contact.
- 4. Device having a poly gate width between 19-22um.
- 5. Device having a mosfer cell pitch between 30-40mm.
- 6. Device having a threshold voltage between 2 and 4 volts.
- Device having an on state resistance (Rdson) of less than approximately 0.8 micro-ohms/micron<sup>2</sup>.
- 8. Device having the ability to hold off a minimum of 1000 volts drain to source.

- If a device has been offered, or will be offered for sale, or used for profit or otherwise publicly disclosed, state when
  and to whom delivered and how used? n/g
- b. Has a printed description of this invention been made available to persons outside the company? How and when and was use restricted (e.g. licensing agreement, non-disclosure agreement, proprietary legends, etc.)?

## Non-Disclosure Agreement

- Provided METAL and PAD data to facilitate manufacture of the bump stencil.
- Test water(s) were sent to facilitate verification of the bump etencit.
- Discussed bumping near the drain contact/trench.

IC Interconnect 1025 Eikton Drive, Colorado Springs, Colorado, USA 80907 Phona: 719-533-1030 Fax: 719-533-1021

Email: ici@icinterconnect.com

13. Inventor(s) Signature(s) (REQUIRED):

	Manager's Comments
14.	How is this igneration important to your products, plans or goals?  FUP CUP 1/16/1 PowdSX Com/648-45 19/25 19/2 IM/643-45
	- FRATULE POPE SIMPLATY IN THE HYBRED ASSOCIALLY FRATUSS HANNE ALL DIS BY SULFOUS MOUT POPE BOTH LOW VOLTAGE
	100 1164 100 100 00 11/100 15 DETOBLE.
15.	Manager's Syptom/required
	Signature Qata Qata
	Manager's Printed Name 1902 P. GSVLISH Mell Step 10=6
	Reminant Unit CAN AND

Manager: Please forward to Patent Section of Law Department, MS 301, upon completion of your review.

\$GDPDC	OCOP Z003G, 04
	Entry constraint: DONTCARE/DONTCARE/DONTCARE/DONTCARE
	Exit constraint: NOCHANGE/NOCHANGE/NOCHANGE/NOCHANGE
SGFNOC	DCOP Z0146.04
	Entry constraint: DONTCARE/DONTCARE/DONTCARE/DONTCARE
	Exit constraint: NOCHANGE/NOCHANGE/NOCHANGE/NOCHANGE
SGFOOD	000P Z004G.03
	Entry constraint: DONTCARE/DONTCARE/DONTCARE/DONTCARE
	Exit constraint: NOCHANGE/NOCHANGE/NOCHANGE/NOCHANGE
SONTOC	DCOP Z038G.02
lassus s m.c.	Entry constraint: DONTCARE/DONTCARE/DONTCARE/DONTCARE
	" "
man ma	Exit constraint: NOCHANGE/NOCHANGE/NOCHANGE
SGPLDC	000P 7002G.03
	Entry constraint: DONTCARE/DONTCARE/DONTCARE/DONTCARE
	Exit constraint: NOCHANGE/NOCHANGE/NOCHANGE
\$GTOX:	STRING DI-PANDA, D2-PANDA
\$LOTMPAN	STRING F7,F5,D5-GUAVA
\$888100	DCOP Z011M.06
	<pre>Entry constraint: DONTCABE/DONTCARE/DONTCARE/ OONTCARE</pre>
	Exit constraint: NOCHANGE/NOCHANGE/NOCHANGE/NOCHANGE
SMTLOP1	STRING ATTK
SNRON	STRING P31_SE11095KEV
SNSDIMP	STRING WCS83-P31_6.0E15095KEV
SPADE	STRING PAD
SPAVIMP	STRING WZ250-B11_2E15035KEV
SPCTOC	DCOP Z018P.02
128 KS 8 KS K	Entry constraint: DONTCARE/DONTCARE/wafers/DONTCARE
acous sometime	Exit constraint: NOCHANGE/NOCHANGE/wefers/NOCHANGE
SPLNINP	STRING WC589-P31_5.OE1504OKEV
SPLYOP	STRING SK_POLY
SPLYPHOS	STRING E4-TUNA
SPNTOC	DCOP Z043P.01
	Entry constraint: DONTCARE/DONTCARE/wafers/DONTCARE
	Exit constraint: NOCHANGE/NOCHANGE/wafers/NOCHANGE
SPPLDC	DCOP Z044P.01
	Entry constraint: DONTCARE/DONTCARE/wafers/DONTCARE
	Exit constraint: NOCHANGE/NOCHANGE/wafers/NOCHANGE
SPSOIMP	STRING W1314-811_5.0E15035KEV
SR2	STRING WTC88-R2A
\$R3	STRING WTCBS-RGA
\$835	STRING WTC88-R35A
\$84	STRING WTC85-R4A
\$85	STRING WYCES-REA
\$86	STRING WTCSS-A6A
SR61	STRING WTCBS-R61A
\$875	STRING WTC8S-R75A
SA8	
SREFLW	STRING D4-8URMA/E2-VEST
\$SECAN	STRING DS-LEMON/FS-LEMON
SSILNITHOP	STRING CPWT685A
SSTMOX	STRING FO-ASPEN

001.000 STARTING\_MATERIAL Location : DIFF

<u>Stage:</u> START

Document :

Desc. :

Traceable: Update Supply Trace Supply Update Dest.

Trace Dest.

Attribute Part PRIMARY 001 WWEPIAA18 <u>Stage:</u> 002.000 CALL\_PROCEDURE DEFAULT Procedure: ZESCRBIP -- 105MM WAFERS Title : WAFER SCRIBE 003.000 CALL\_PROCEDURE Procedure: ZENITSSG Stagei DEFAULT Title : ACTIVE EXPOSE AND ETCH DEFAULT 004.000 CALL\_PROCEDURE <u>Stage:</u> Procedure: ZEFLD5DM : DMOS/ FIELD OX AND NTR REMOVAL Title CALL\_PROCEDURE <u>Stage:</u>
Procedure: ZENRONDMS 005.000 CALL\_PROCEDURE : N+ IMPLANT/GATE OXIDATION MODULE DMOS Title 006.000 CALL PROCEDURE <u>Stage:</u> DEFAULT Procedure: ZEPDP3SG Title : 3u SAG W/POLY DEP/PHOS & IMPL. 007.000 CALL\_PROCEDURE <u>Stage:</u> Procedure: ZEPLYSDMS : POLY EXPOSE & ETCH DMOS <u>Stage:</u> 008,000 CALL PROCEDURE Procedure: ZEPSDYIM ; P BODY & P+AVALANCHE IMPLANT/DRIVE MODULE Title 009,000 CALL PROCEDURE Stagel DEFAULT Procedure: ZEPSD56G Title : P+S/D EXPOSE AND IMPLANT 010.000 CALL\_PROCEDURE <u>Stage:</u> DEFAULT Procedure: ZENSOSSG : N+S/D MASK AND IMPLANT 5u VALL\_PROCEDURE Stage:
Procedure: ZEIDODNO 011.000 CALL PROCEDURE Title : INTERLAYER DOPED OXIDE/WITHOUT ARGON IMPLANT CALL\_PROCEDURE Stage:
Procedure: ZECTN58G 012,000 CALL PROCEDURE Title : CONTACT STEPPER & ETCH 5u (NO CRSI) 013.000 CALL\_PROCEDURE <u>Stage:</u> DEFAULT Procedure: ZEBSCONTACT Title : BACKSIDE CONTACT MODULE FOR HIGH POWER MOSFET 014.000 CALL\_PROCEDURE Stage: Procedurs: ZEMLODMS : METAL DEP \$MTLDP1 LIFTOFF Title 015.000 CALL\_PROCEDURE <u>Stage:</u> Procedure: ZEPADBIP DEFAULT Title : PAD MODULE 016.000 CALL PROCEDURE Stage: DEFAULT Procedure: ZEFANEAL Procedure: Lerandal Title : FINAL ANNEAL MODULE 450 DEG 017.000 CALL\_PROCEDURE <u>Stage:</u> DEFAULT Procedure: ZEKETHLY

Title : KEITHLEY PROBE MODULE 018.000 CALL\_PROCEDURE <u>Stage:</u> Procedure: ZESGRALL DEFAULT Titls : BACKGRIND MODULE - all processes 019.000 GALL PROCEDURE <u>Stage:</u> Procedure: ZEBSMETAL Title : METAL DEP WAFER BACKSIDE (CALL ENG) 020.000 CALL\_PROCEDURE <u>Stage:</u> DEFAULT Procedure: ZEFINVIS Title : Final Visual Inspection w/o pop. 021.000 CALL\_PROCEDURE DEFAULT <u>Stage:</u> Procedure: ZETRNFER Title : WAFER TRANSFER 022.000 MOVE\_TO\_LOCATION Stage: ENGINV Location : ENGINV

\*\*\*\*\*\*

Procedure : WTC88-001A.04 PLANNABLE

Title

: Sµ DMOS W/BSCONTACT HIGH POWER MOSFET 150MM

Owner

: FIX

Date created

**08:00** 

Status

: ACTIVE NOSTARTS

Date last changed:

16:29

🌉 s category: **09:48** 

Date activated

Pouedure usage: PRIMARY PROCEDURE

Main prod area

: WAFERFAB

€CN

Document

: DEVICE

WTCBS-001A.04

<u>Material constraints</u>

Processing state Main-Material type Sub-Material

type

Entry: Nothing

Nothing

Nothing

Nothing

Exit: Identified

Normal

W = waters

Nothing

No category has been specified.

No output part has been specified.

No material type conversions have been specified.

Paramater

Type Value

SBOIMP

STRING WI660-811\_1.6E14@40KEV

\$BKGRNO

STRING 19 NIL

\$CAPOX

SDCODC

STRING D8-ORCID

\$0

STRING WTCBS-001A 21290.02

DCOP

Entry constraint: DONTCARE/DONTCARE/DONTCARE/DONTCARE

Exit constraint: NOCHANGE/NOCHANGE/NOCHANGE/NOCHANGE

SDFOOC

9009 Z0870.01

Entry constraint: DONTCARE/DONTCARE/DONTCARE/DONTCARE

Exit constraint: NOCHANGE/NOCHANGE/NOCHANGE 21470.01

9000

Entry constraint: DONTCARE/DONTCARE/DONTCARE/DONTCARE Exit constraint: NOCHANGE/NOCHANGE/NOCHANGE

SOPOX SORFOC STRING 7K 7 PSG

9009 Z090D.01

Entry constraint: DONTCARE/DONTCARE/DONTCARE/DONTCARE

Exit constraint: NOCHANGE/NOCHANGE/NOCHANGE/NOCHANGE

SDSTDC Z0880.01

Entry constraint: DONTCARE/DONTCARE/DONTCARE/DONTCARE

Exit constraint: NOCHANGE/NOCHANGE/NOCHANGE

SECTOC STRING NO DATA NEEDED

SENTOC Z060E.01 9009

Entry constraint: DONTCARE/DONTCARE/wafers/DONTCARE

Exit constraint: NOCHANGE/NOCHANGE/wafers/NOCHANGE

SFLOOX STRING 07-WHITE, F3-WHITE

STRING 4KOX\_4KNIT \$FNLPAS